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Attorney Docket 0524-0136.01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)	
Tomotaka Yokoyama et al	I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:
Serial No.: 10/761,771	Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on
Filed: January 20, 2004)	March 8, 2005 (Date of Deposit)
For: Management Technique Of Friction) Coefficient Based On Surface Roughness,) Substrate For An Information Recording) Medium, Information Recording Medium) And Manufacturing Method Thereof)	Shannon Wallace Name of applicant, assignee, or Registered Rep. Signature Signature Date
Art Unit: 1773	
Examiner: Leszek B. Kiliman)	
Commissioner for Patents	

RESPONSE TO OFFICE ACTION AND AMENDMENT (A)

Sir:

Alexandria, VA 22313-1450

Applicants have the following response to the Office Action of September 9, 2004.